

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 19, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

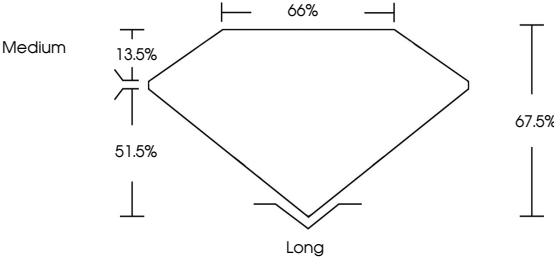
Inscription(s)


Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG665451320

Report verification at [igi.org](https://www.igi.org)

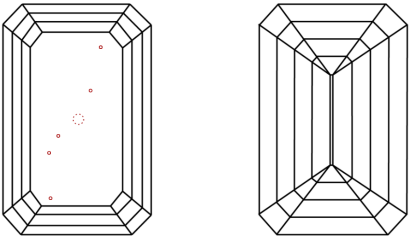
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR


D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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LABORATORY GROWN DIAMOND

EMERALD CUT

11.40 X 8.16 X 5.51 MM

5.03 CARATS

F

VS 2

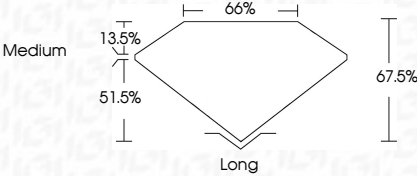
EXCELLENT

EXCELLENT



NONE

IGI LG665451320

PROPORTIONS




IGI



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November 19, 2024

IGI Report No LG665451320

EMERALD CUT

11.40 X 8.16 X 5.51 MM

5.03 CARATS

F

VS 2

67.5%

66%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI LG665451320

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